Application No.	Applicant(s)
10/612.992	UETAKE, TOSHIYUKI
Examiner	Art Unit
Mai-Huong Tran	2818
IGHTS. This application is subject t	correspondence address oplication. If not included in will be mailed in due course. THIS to withdrawal from issue at the initiative
kaminer.	
of this communication to file a reply //ENT of this application.	complying with the requirements
nitted. Note the attached EXAMINER es reason(s) why the oath or declara	
son's Patent Drawing Review (PTO . s Amendment / Comment or in the (l.84(c)) should be written on the drawl the header according to 37 CFR 1.121	Office action of lings in the front (not the back) of (d).
FOR THE DEPOSIT OF BIOLOGIC	
6. Interview Summary Paper No./Mail Da D8), 7. Examiner's Amend 8. Examiner's Statem 9. Other David Nelms Visory Patent Examiner	ate
	Examiner Mai-Huong Tran Pars on the cover sheet with the cover sheet shee

DETAILED ACTION

Reason for allowance

The following is an examiner's statement of reason for allowance: None of the references of record teaches or suggests the claimed Semiconductor Storage Device with Signal Wiring Lines RMED above Memory Cells having a conductive shield layer disposed in a fourth wiring layer between the second and third wiring layers, the conductive shield layer including there-inside the bit lines in a first area including an area where the bit lines and the signal wiring lines are superposed upon each other, as viewed along a direction vertical to the surface of the semiconductor substrate, openings being formed through the conductive shield layer in areas where the bit lines are not disposed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance".

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Mai-Huong Tran whose telephone number is (571)-272-1796. The examiner can normally be reached on Monday-Thursday 8:00am-6:30pm.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on (571) 272-1787. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 872-9306 for regular communications and (703) 308-7722 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 872-9319.

Mai-Huong Tran

Supervisory Patent Examiner
Technology Center 2800

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